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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): George D. Papasouliotis, Robert D. Tas, Patrick A. Van Cleemput,  
Bart van Schravendijk  
Assignee: Novellus Systems  
Title: Process For Depositing F-Doped Silica Glass In High Aspect Ratio  
Structures  
Application No.: 10/035,773 Filing Date: December 21, 2001  
Patent No.: 6,846,391 B1 Issue Date: January 25, 2005  
Examiner: Julian A. Mercado Group Art Unit: 1745  
Docket No.: M-5091-2P US

San Jose, California  
September 1, 2005

Certificate

SEP 1 2 2005

of Correction

Attn: Certificate of Correction Branch  
Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

PETITION FOR ENTRY OF CERTIFICATE OF CORRECTION

Sir:

Please enter the enclosed Certificate of Correction (Form PTO 1050) in the above patent. The errors sought to be corrected were made by the Patent and Trademark Office. Thus, no fee is required for the Certificate of Correction pursuant to 37 C.F.R. § 1.322. However, the Commissioner is hereby authorized to charge any fee which may be required for this correction to Deposit Account No. 50-2257.

Please direct all inquiries concerning this request to the undersigned attorney at (408) 392-9250. This form is submitted in duplicate.

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Certificate of Correction Branch, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on September 1, 2005.

Attorney for Applicant(s)

Date of Signature

Respectfully submitted,

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U.S. Patent No. 6,846,391 B1

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INVENTOR(S) : George D. Papasouliotis, Robert D. Tas, Patrick A. Van Cleemput, and Bart van Schravendijk

It is certified that an error appears or errors appear in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Col. 7, line 28, Claim 26

Delete "if first" and replace with --first--.

**MAILING ADDRESS OF SENDER (Please do not use customer number below):**

Macpherson Kwok Chen & Heid LLP  
1762 Technology Drive, Suite 226  
San Jose, California 95110

This collection of information is required by 37 CFR 1.322, 1.323, and 1.324. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 1.0 hour to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: **Attention Certificate of Corrections Branch, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.**

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